



**ELECTRONIC COPY**

LG760513292  
Report verification at igi.org



December 26, 2025

IGI Report Number **LG760513292**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **9.96 X 7.33 X 4.91 MM**

**GRADING RESULTS**

Carat Weight **3.07 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

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MODIFIED BRILLIANT**

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**GRADING RESULTS**

Carat Weight **3.07 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

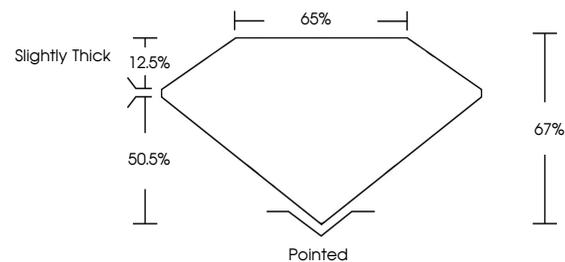
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG760513292**

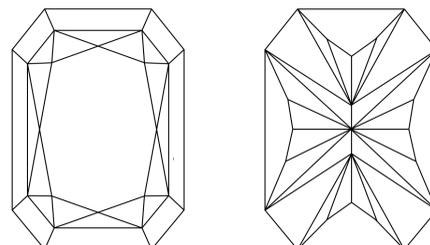
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

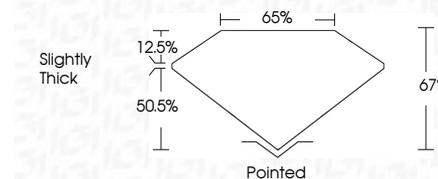
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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CUT CORNERED RECT. MODIFIED BRILLIANT  
3.07 CARATS  
E  
9.96 X 7.33 X 4.91 MM  
Color Grade  
VVS 2  
Depth 67%  
Table 50.5%  
Girdle  
Slightly Thick  
Pointed  
Culet  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG760513292

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